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November 26, 2003

ATTORNEY DOCKET NO. 03180.0342  
CUSTOMER NO. 22,852



**Mail Stop Patent Application**

**Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450**

New U.S. Patent Application  
Title: RETICLE, EXPOSURE MONITORING METHOD,  
EXPOSURE METHOD AND MANUFACTURING  
METHOD FOR SEMICONDUCTOR DEVICE  
Inventor: Nobuhiro KOMINE Tokyo, Japan

Sir:

We enclose the following papers for filing in the United States Patent and Trademark Office in connection with the above patent application.

1. Application- 42 pages, including 4 independent claims and 25 claims total.
2. Drawings- 12 sheets of drawings containing 22 Figures.
3. Certified copy of Japanese Patent Application No. 2002-342798, filed November 26, 2002.
4. Information Disclosure Statement and Information Disclosure Citation, PTO 1449 with 2 documents attached.
5. The filing fee is calculated as follows:

Basic Application Filing Fee					\$770	\$ \$770.00
	Number of Claims		Basic	Extra Claims		
Total Claims	25	-	20	5	x \$18	\$ 90.00
Independent Claims	4	-	3	1	x \$86	\$ 86.00
<input type="checkbox"/> Presentation of Multiple Dep. Claim(s)					+\$290	
Subtotal						\$ 946.00
Reduction by 1/2 if small entity						-
TOTAL APPLICATION FILING FEE						\$ 946.00

6. A check for \$946.00 is enclosed. The fee includes:

\$770.00 filing fee; and  
\$176.00 additional claims fee.

This application is being filed under the provisions of 37 C.F.R. § 1.53(f).  
Applicant awaits notification from the Patent and Trademark Office of the time set for filing the Declaration.

Applicant claims the right to priority based on Japanese Patent Application No. 2002-342798, filed November 26, 2002.

Please address all correspondence with respect to this application to:

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Washington, D.C. 20005-3315

Please accord this application an application number and filing date.

Commissioner of Patents  
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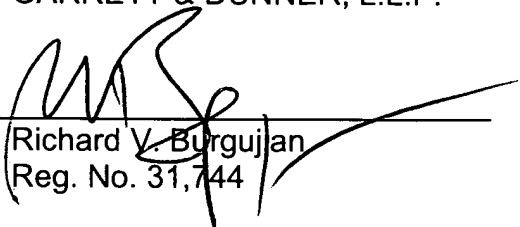
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The Commissioner is hereby authorized to charge any additional filing fees due and any other fees due under 37 C.F.R. § 1.16 or §1.17 during the pendency of this application to our Deposit Account No. 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,  
GARRETT & DUNNER, L.L.P.

By: \_\_\_\_\_

  
Richard V. Burgujan  
Reg. No. 31,744

RVB/FPD/sem  
Enclosures